



EL465779215

Inventor: Chris Parf niuk et al.

Title: Methods of Bonding First and Second Masses to One Another, and Methods of Bonding Physical Vapor Deposition Target Materials To Backing Plate Materials

Assignee: Honeywell International, Inc.

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**INFORMATION DISCLOSURE STATEMENT**  
**PURSUANT TO 37 C.F.R. §§ 1.56, 1.97 AND 1.98**

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, the Examiner's attention is directed to the references listed on the attached Form PTO-1449 and copies of which are attached. No admission is made regarding whether all the submitted references are prior art.

Citation of these references is respectfully requested.

Respectfully submitted,

Date: 11/13/01

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